



Practitioner's Docket No.: 791\_075 DIV

*Richard A. A'G/10/02*  
PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the application of: Yukihiisa TAKEUCHI, Tsutomu NANATAKI,  
Toshikazu HIROTA and Koji KIMURA

Ser. No.: 09/963,696

Art Unit: 2834

Filed: September 26, 2001

Examiner: Not Assigned

Confirmation No.: 2017

For: PIEZOELECTRIC/ELECTROSTRICTIVE DEVICE AND PRODUCTION  
METHOD THEREOF

Assistant Commissioner for Patents  
Washington DC 20231

I hereby certify that this correspondence is being deposited with  
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Assistant Commissioner for Patents, Washington D.C. 20231  
on November 7, 2001.

*Tara L. Preston*  
Tara L. Preston

**PRELIMINARY AMENDMENT**

Sir:

Prior to examination of the above-identified application on the merits, please amend the  
application as follows:

**In the Claims:**

Please add new claims 14-18 as follows:

14. (NEW) A method of fabricating a piezoelectric/electrostrictive device according to  
claim 5, wherein said method includes a step of laminating on a surface constituting the  
outermost layer of said ceramic green laminate having at least one hole, when laminating at  
least a plurality of ceramic green sheets having at least a hole formed thereon, a ceramic green  
sheet having at least one hole formed thereon which is mounted on a plastic film in such a  
manner that said plastic film is placed as a new outermost layer, and removing said plastic  
film after the holes are accurately aligned.